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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2814**

PATENT

Customer No. 22,852

Attorney Docket No. 04329.1952-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|-------------------------------|---|----------------------------|
| In re Application of: |) | |
| |) | |
| Yoshitaka TSUNASHIMA et al. |) | Group Art Unit: 2814 |
| |) | |
| Application No.: 09/688,989 |) | Examiner: Shrinivas H. RAO |
| |) | |
| Filed: October 17, 2000 |) | Confirmation No.: 2408 |
| |) | |
| For: SEMICONDUCTOR DEVICE AND |) | |
| METHOD OF MANUFACTURING |) | |
| THE SAME |) | |

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed December 21, 2005, the period for response extends through March 21, 2006, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.